



**ELECTRONIC COPY**

## LABORATORY GROWN DIAMOND REPORT

May 19, 2025	
IGI Report Number	LG705535000
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MODIFIED BRILLIANT
Measurements	8.01 X 5.69 X 3.71 MM

## GRADING RESULTS

Carat Weight	1.51 CARAT
Color Grade	D
Clarity Grade	VVS 2

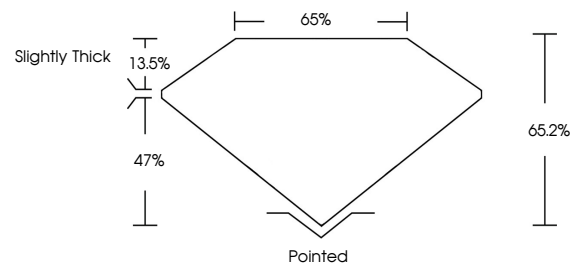
### ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG705535000

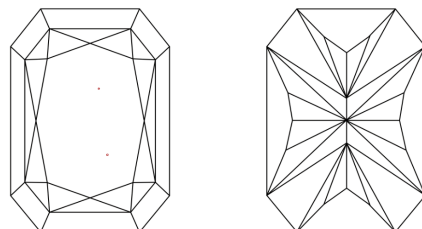
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

LG705535000  
Report verification at [igi.org](http://igi.org)

## PROPORTIONS

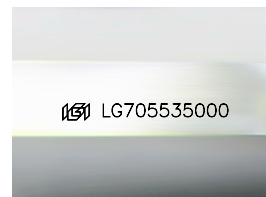


## CLARITY CHARACTERISTICS



### KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.



Sample Image Used

## COLOR

D E F G H I J Faint Very Light Light

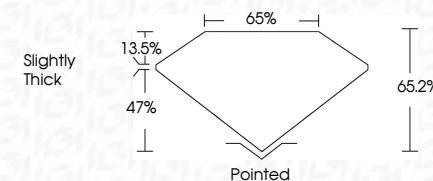
## CLARITY

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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